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Date of Deposit: December 8, 2005 December 12, 2005  
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Robert Faber 12-12-05 RCF  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of : Date: December 8, 2005  
Dureseti Chidamarrao, et al. : Group Art Unit: 2813  
Serial No: 10/715,400 : Examiner: James Mitchell  
Filed: 11/19/03 : International Business Machines Corporation  
2070 Route 52  
Hopewell Junction, NY 12533

TITLE: SILICON DEVICE ON SI:C-OI AND SGOI AND METHOD OF MANUFACTURE

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the US and non-US patents and publications as listed on Form PTO-1449, attached hereto.

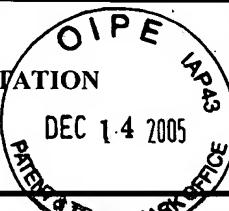
In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,  
Dureseti Chidamarrao, et al.

By

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**INFORMATION DISCLOSURE CITATION**
*(Use several sheets if necessary)*
**Docket Number (Optional)**
**FIS920030242US1**
**Application Number**
**10/715,400**
**Applicant(s)**
**Dureseti Chidambarrao, et al.**
**Filing Date**
**11/19/03**
**Group Art Unit**
**2813**
**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,940,716	08/17/99	Jin, et al.			
		5,981,356	11/09/99	Hsueh, et al.			
		6,080,637	06/27/00	Huang, et al.			
		6,093,621	07/25/00	Tseng			
		6,583,060	06/24/03	Trivedi			

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS**
*(Including Author, Title, Date, Pertinent Pages, Etc.)*


**EXAMINER**
**DATE CONSIDERED**
**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.